Amendments to the Claims:

Please amend the claims to read as follows:

1. (currently amended) A system comprising: 1 a charge-emission device having an emitter; and 2 a controllable current source electrically connected to the emitter of the charge-3 4 emission device by an electrical path, the controllable current source supplying to the 5 emitter of the charge-emission device over the electrical path a controlled amount of 6 electrical current that produces a potential difference at the emitter with respect to an electrode to induce the emitter to emit electrical charge; and 7 8 a current sink connected to the controllable current source for shunting at least a 9 portion of the electrical current to ground upon a detection of a particular charge emission 10 condition. 2. 1 (canceled) 1 3. (currently amended) The system of claim 21, further comprising protection circuitry for 2 detecting the particular charge emission condition and for activating the current sink upon 3 the detection. (currently amended) The system of claim 21, wherein the particular charge emission 1 4. 2 condition is indicative of an excessive flow of current from the emitter.

PAGE 6/16 * RCVD AT 2/22/2005 1:40:40 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-1/1 * DNIS:8729306 * CSID:5083030005 * DURATION (mm-ss):04-32

- 1 5. (currently amended) The system of claim 21, wherein the particular charge emission
 2 condition is indicative of an excessive rate of change of the current flowing from the
 3 emitter.
 1 6. (original) The system of claim 1, wherein the current source is adjustable to enable
- 2 changes to an amount of electrical current being supplied by the controllable current
 3 source to the emitter.
- 7. (original) The system of claim 1, further comprising a controller directing the controllable current source to provide a predetermined amount of electrical current.
- 1 8. (original) The system of claim 1, wherein the charge-emission device is a device that
 2 emits ions.
- 1 9. (original) The system of claim 8, wherein the emitted ions have a positive charge.
- 1 10. (original) The system of claim 1, wherein the charge-emission device is a device that
 2 emits electrons.
- 1 11. (original) The system of claim 1, wherein the charge-emission device emits fluid.
- 1 12. (original) The system of claim 1, wherein the charge-emission device is a gated device.

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(original)

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1	13.	(original) The system of claim 1, wherein the charge-emission device has an array of		
2	emitters including the emitter and a second emitter, and the controllable current s			
3		provides current to each emitter in the emitter array.		
1	14.	(original) The system of claim 1, wherein the controllable current source is a first		
2		current source, the charge-emission device has an array of emitters including a first		
3		emitter and a second emitter, and further comprising a second controllable current source		
4		the first current source supplying a first controlled amount of electrical current to the first		
5		emitter and the second current source supplying a second controlled amount of current to		
б		the second emitter.		
1	15.	(currently amended) A system comprising:		
2		a micro-fabricated charge-emission device having an emitter; and		
3		controllable means for supplying to the emitter of the charge-emission device a		
4		controlled amount of electrical current that produces a potential difference at the emitter		
5		with respect to an electrode to induce the emitter to emit electrical charge; and		
6		means for shunting at least a portion of the supplied electrical current to ground		
7		upon a detection of a particular condition.		
1	16.	(original) The system of claim 15, further comprising means for signaling the		
2		supplying means to supply the controlled amount of electrical current		

controlled amount of electrical current supplied to the emitter.

The system of claim 15, further comprising means for adjusting the

1	18.	(canceled)

- 1 19. (original) The system of claim 15, further comprising means for detecting a
- 2 particular charge emission condition.
- 1 20. (currently amended) A method of controlling an amount of charge emitted by a charge-
- 2 emission device, the method comprising:
- 3 supplying a controlled amount of current from a controllable current source to an
- 4 emitter of a charge-emission device over an electrical path; and
- 5 emitting charge from the emitter of the charge-emission device in response to the
- 6 current received from the controllable current source; and
- 7 shunting the current supplied by the controlled current source to ground upon a
- 8 <u>detection of a particular charge emission condition.</u>
- 1 21. (original) The method of claim 20, further comprising adjusting the amount of
- 2 clectrical current supplied to the emitter by the controlled current source.
- 1 22. (canceled).
- 1 23. (currently amended) The method of claim 20, further-comprising wherein shunting the
- 2 supplied current in response to includes detecting an excessive rate of change in an
- amount of charge being emitted by the emitter.

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- 1 24. (currently amended) The method of claim 20, further comprising wherein shunting the
 2 supplied electrical current in response to includes detecting an excessive amount of
 3 charge being emitted by the emitter.
 - 25. (new) A system comprising:
 - a charge-emission device having an emitter and a gate electrode; and
 a controllable current source electrically connected to the emitter of the chargeemission device by an electrical path over which the controllable current source supplies
 a controlled amount of electrical current to the emitter, the supplied amount of electrical
 current producing a voltage difference between the emitter and the gate electrode of a
 magnitude sufficient to cause the emitter to emit electrical charge without having to use a
 voltage supply to apply a voltage bias to the gate electrode in order to achieve the voltage
 difference that causes emission of the electrical charge.
- 1 26. (new) The system of claim 25, wherein the charge-emission device is micro-fabricated
 2 and the gate electrode is integrated with the emitter in a micro-fabricated structure.
- 1 27. (new) The system of claim 25, further comprising means for signaling the current source
 2 to supply the controlled amount of electrical current.
- 1 28. (new) The system of claim 25, further comprising means for adjusting the controlled amount of electrical current supplied to the emitter.

- (new) The system of claim 25, further comprising a current sink connected to the 29. ı controllable current source for shunting at least a portion of the electrical current to 2 ground upon a detection of a particular charge emission condition. 3
- 1 30. (new) The system of claim 29, further comprising protection circuitry for detecting the 2 particular charge emission condition and for activating the current sink upon the 3 detection.
- 1 31. (new) The system of claim 29, wherein the particular charge emission condition is 2 indicative of an excessive flow of current from the emitter.
- 32. l (new) The system of claim 25, wherein the charge-emission device has an array of 2 emitters including the emitter and a second emitter, and the controllable current source 3 provides current to each emitter in the emitter array,
- 1 (new) The system of claim 25, wherein the controllable current source is a first current 33. 2 source, the charge-emission device has an array of emitters including a first emitter and a 3 second emitter, and further comprising a second controllable current source, the first 4 current source supplying a first controlled amount of electrical current to the first emitter 5 and the second current source supplying a second controlled amount of current to the 6 second emitter.

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1 34. (new) A method of controlling an amount of charge emitted by a charge-emission device 2 having an emitter and a gate electrode, the method comprising:

supplying a controlled amount of current from a controllable current source to the emitter of the charge-emission device over an electrical path; and

producing, by the controlled amount of current, a voltage difference between the emitter and the gate electrode of a magnitude sufficient to cause the emitter to emit electrical charge without having to use a voltage supply to apply a voltage bias to the gate electrode in order to achieve the voltage difference that causes emission of the electrical charge.

- 1 35. (new) The method of claim 34, further comprising adjusting the amount of electrical current supplied to the emitter by the controlled current source.
- 1 36. (new). The method of claim 34, further comprising shunting the current supplied by the controlled current source to ground upon a detection of a particular charge emission condition.
- 1 37. (new) The method of claim 36, wherein shunting the supplied current includes detecting
 2 an excessive rate of change in an amount of charge being emitted by the emitter.
- 1 38. (new) The method of claim 36, wherein shunting the supplied electrical current includes
 2 detecting an excessive amount of charge being emitted by the emitter.